







Quantum Dot Intersubband Photodetectors for LWIR photons

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1024 $\lambda_c = 5 \ \mu m$ 1022 Mature technology 5 Detectivity (cmHz^{w2}W¹) QDIP(n=2%)1020 High quantum efficiency (~70%) \checkmark QWIP(n=33%) 1018 HgCdTe HTSC -1016 Can be tuned in the range 1-30 µm m=35% \checkmark 1014 Photoemissive K Low growth uniformity m=0.7% 1012 Extrinsi (n=35%) **Extremely high cost** 1010 80 100 120 140 160 20 60 40 Temperature (K)

Rogalski et al., J. Appl. Phys. 105, 091101 (2009)









QWIP (Quantum Wel

✓ Mature technology

- Short carrier lifetime (lower quantum efficiency)
- Only IR radiation parallel to the QW is detected
- High growth uniformity
 - Lower cost



Rogalski et al., J. Appl. Phys. 105, 091101 (2009)









2DIP (Quantum Dot

Technology based on well estabilshed GaAs technology

- Low dark current due to lower thermal emission
- High optical absorption at normal incidence
- Possible high operating temperature (Peltier cooling -80°C)



Rogalski et al., J. Appl. Phys. 105, 091101 (2009)









The decrease in **detectivity** with **temperature** is a crucial issue.

Up to now external cooling is always required to improve S/N ratio.

- Increased complexity
- Reduced device lifetime in space satellites























- Small capture
- Low thermalization efficiency (phonon bottleneck)
- Low escape probability (phonon bottleneck)
- Large absorption coefficient
- Ok extraction (tunneling)

Increase capture and **thermalization** efficiencies without increasing the escape probability.

Capture and thermalization are very efficient in **2D nanostructures.**

OD nanostructures have low escape probability and high absorption coefficient.

What if we can combine these advantages?









We designed and realized by **Droplet Epitaxy** a hybrid **OD-2D nanostructure** (QDs on top of a QW) made of GaAs/AlGaAs.

The absence of a potential barrier between 0D and 2D allows to spatially **modulate** the properties **quantum confinement**.

QD-like low energy states QW-like high energy states















The QW introduces **resonant states** in CB, E>E_{CB} with a localization in the QD region -> large absorption probaility



Vichi et al., ACSPhotonics 12,447-456 (2025)











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- Small capture
- Low thermalization efficiency
 (phonon bottleneck)
- Low escape probability (phonon bottleneck)
- Large absorption coefficient
- Ok extraction (tunneling)

- Large capture
- High thermalization efficiency (carrier-carrier scattering)
- Low escape probability (phonon bottleneck)
- Good absorption coefficient
 - Large extraction (resonant states)



Vichi et al., ACSPhotonics 12,447-456 (2025)









Droplet Epitaxy

Two-step growth of self-assembled QDs:

- Deposition of group III to form metal droplets
- **Crystallization** with group V flux

Advantages:

- Strain-free growth
- Independent control on QD
 morphological parameters
 (height, aspect ratio, shape)
- Narrow size dispersion



Gurioli et al., Nat. Mater. 18, 799 (2019)























CONCLUSIONS:

Innovative quantum state design to **modulate quantum confinement**:

- **OD** ground state
- 2D excited states
 To exploit the advantages of both nanostructures.

Achieved room temperature operation $R = 2*10^{-4} A/W$

Vichi et al., ACS Photonics 12,447-456 (2025)











EXTRA SLIDES











Ga droplet deposition









Droplet deposition: Ga amount --> droplet volume **Temperature** --> droplet density

Crystalization controls geometry:

- As incorporation in the droplet and 1) crystalization at the liquid-solid interface
- 2) As adsorption on the surface and crystalization after Ga out-diffusion



As Droplet Ga Substrate Process 1: Crystallization Process 2: Crystallization after diffusion out of the droplet at liquid-solid interface Z: 35.0nm Z: 7.7nm















How to change **R** without changing h? Increase **diffusion length**

How to change **h** without changing R? Increase **droplet volume**



DE-QD shape engineering



Steinhoff et al., Physical Review B 88, 205309 (2013)

Scaccabarozzi et al., Prog Photovolt Res Appl. 31, 637 (2023)